

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79703

Hisayuki MIKI, et al.

Appln. No.: 10/586,849

Group Art Unit: 2811

Confirmation No.: 3462

Examiner: Unknown

Filed: July 20, 2006

For: GALLIUM NITRIDE-BASED COMPOUND SEMICONDUCTOR MULTILAYER
STRUCTURE AND PRODUCTION METHOD THEREOF

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

ATTN: Office of Initial Patent Examination
Filing Receipt Correction
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction:

Assignment for Published Patent Application

SHOWA DENKO K.K.

Verification for the requested correction is indicated on the Executed Assignment Document filed July 20, 2006.

Respectfully submitted,

Abraham J. Rosner
Registration No. 33,276

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: April 24, 2007



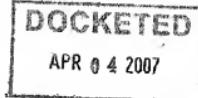
UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
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APPL NO.	FILING OR 371(C) DATE	ART UNIT	FIL FEE RECD	ATTY.DOCKET NO	TOT CLMS	IND CLMS
10/586,849	07/20/2006	2811	1750	Q79703	37	2

CONFIRMATION NO. 3462

23373
 SUGHRUE MION, PLLC
 2100 PENNSYLVANIA AVENUE, N.W.
 SUITE 800
 WASHINGTON, DC 20037



FILING RECEIPT



OC00000023131630

Date Mailed: 03/30/2007

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Hisayuki Miki, Chiba, JAPAN;
 Tetsuo Sakurai, Chiba, JAPAN;
 Hitoshi Takeda, Chiba, JAPAN;

ASSIGNMENT FOR PUBLISHED PATENT APPLICATION SHAWA DENKO K.K.
 Power of Attorney: The patent practitioners associated with Customer Number 23373.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP05/01642 01/28/2005
 which claims benefit of 60/541,069 02/03/2004

Foreign Applications

JAPAN 2004-021479 01/29/2004

If Required, Foreign Filing License Granted: 03/27/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US10/586,849

Projected Publication Date: 07/06/2007

Non-Publication Request: No

U.S. ASSIGNMENT

IN CONSIDERATION of the sum of One Dollar (\$1.00), and of other good and valuable consideration paid to
the undersigned inventor(s) (hereinafter "ASSIGNOR") by

(Insert
ASSIGNEE's
Name(s)
Address(es))

SHOWA DENKO K.K.

13-9, Shiba-daimon 1-chome, Minato-ku, Tokyo 105-8518, Japan

(hereinafter "ASSIGNEE"), the receipt of which is hereby acknowledged, the undersigned ASSIGNOR hereby sells, assigns and
conveys to ASSIGNEE the entire and exclusive right, title and interest to the invention entitled

**Title of
Journal**

GALLIUM NITRIDE-BASED COMPOUND SEMICONDUCTOR MULTILAYER STRUCTURE AND PRODUCTION METHOD THEREFOR

cating to International Patent Application PCT/JP 2005/001642 and/or for which application for Letters Patent
in the United States was prosecuted on such date herewith or, if not so executed, will

(Insert date
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of application,
if not
concurrent)

(e) executed on _____

(b) filed on _____
Serial No. _____

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and to said application and all Letters Patent(s) of the United States granted on said application and any continuation, divisional, substitute, reissue or continuation-in-part application filed thereon, for the full term or terms for which the said Letters Patent(s) may be granted and including any extension thereof (collectively, hereinafter, "said application(s) and Letters Patent(s)");

The ASSIGNOR agrees that, when requested by said ASSIGNEE and without charge to but at the expense of said ASSIGNEE, to do all acts which the ASSIGNEE may deem necessary, desirable or expedient, for the securing, maintaining and enforcing protection for said invention, including in the preparation and presentation of said application and in the prosecution of said Letters Patent, or in any investigation, research, examinations, or proceedings before any patent office or in any tribunal or other legal proceeding which may arise or be desired in relation to said invention, so far as to facilitate but not be limited to amending all papers, including separate assignments and declarations, taking all right and, providing sworn testimony, and obtaining and

IN WITNESS WHEREOF, the undersigned inventor(s) has (have) affixed his/her/their signature(s).

(Signature)	<u>Hisayuki Miki</u> (SIGNATURE)	Hisayuki Miki (TYPE NAME)	May 22, 2006 (DATE)
	<u>Tetsuo Sakurai</u> (SIGNATURE)	Tetsuo Sakurai (TYPE NAME)	May 22, 2006 (DATE)
	<u>Hitoshi Takeda</u> (SIGNATURE)	Hitoshi Takeda (TYPE NAME)	May 22, 2006 (DATE)
	(SIGNATURE)	(TYPE NAME)	(DATE)
	(SIGNATURE)	(TYPE NAME)	(DATE)
	(SIGNATURE)	(TYPE NAME)	(DATE)
	(SIGNATURE)	(TYPE NAME)	(DATE)
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